SuperSharpSilicon™- Force Modulation Mode

NANOSENSORS™ SSS-FM AFM probes are designed for force modulation mode.

For enhanced resolution of nanostructures and microroughness we offer our **SuperSharpSilicon™** AFM tip with unrivalled sharpness.

The FM type is offered for force modulation microscopy. The force constant of this AFM probe spans the gap between contact and non-contact mode and is specially tailored for the force modulation mode. The **SSS-FM** tip serves also as a basis for high resolution AFM tips with magnetic coatings (<u>SSS-MFMR</u>). Furthermore non-contact or tapping mode operation is possible with the FM tip but with reduced operation stability.

The AFM probe offers unique features:

- guaranteed AFM tip radius of curvature < 5 nm
- typical AFM tip radius of curvature of 2 nm
- typical aspect ratio at 200 nm from tip apex in the order of 4:1
- half cone angle at 200 nm from apex < 10°
- monolithic material
- highly doped to dissipate static charge
- chemically inert
- high mechanical Q-factor for high sensitivity

Cantilever data:

| Property | Nominal Value | Specified Range |
|------------------------------|---------------|-----------------|
| Resonance Frequency [kHz] | 75 | 45 - 115 |
| Force Constant [N/m] | 2.8 | 0.5 - 9.5 |
| Length [µm] | 225 | 215 - 235 |
| Mean Width [μm] | 30 | 20 - 35 |
| Thickness [µm] | 3 | 2 - 4 |

Order codes and shipping units:

| Order Code | AFM probes per pack | Data sheet |
|------------|---------------------|---------------|
| SSS-FM-10 | 10 | of all probes |
| SSS-FM-20 | 20 | of all probes |
| SSS-FM-50 | 50 | |